Update on Micro-channel cooling inside silicon sensors



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(2)



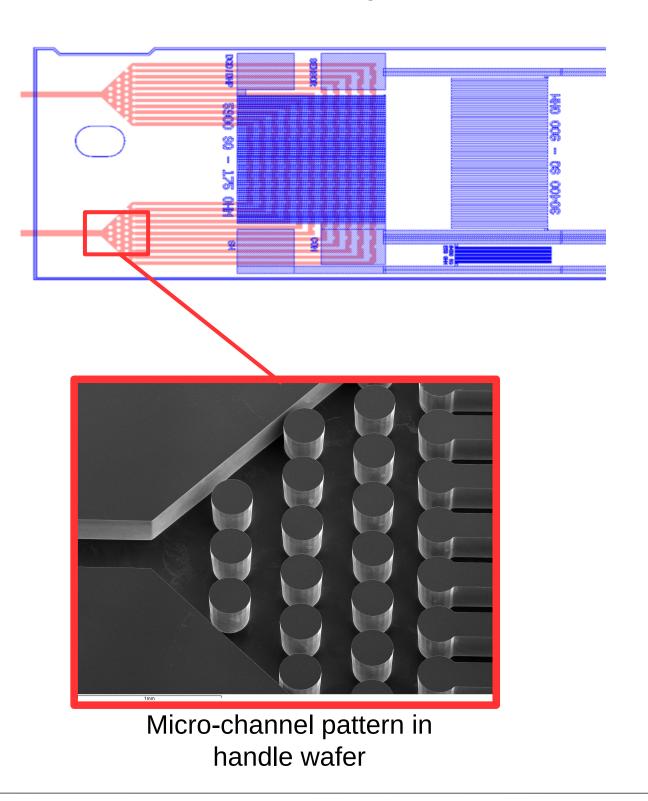
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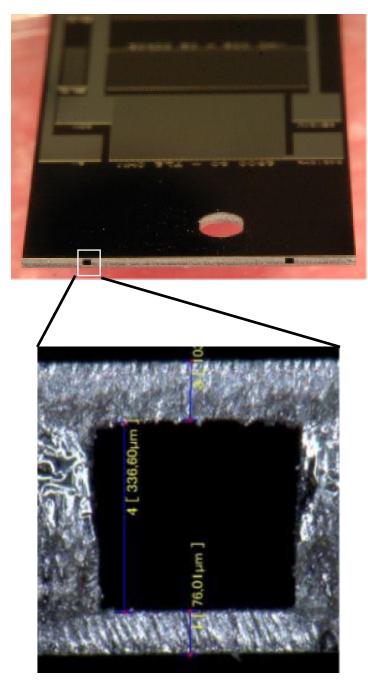
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Outline

- 1- Introduction of the setup
- 2- Past results and main issues to address
- 3- Present results and mcc optimization
- 4- Summary

The resistive dummies with integrated micro-channels based in DEPFET layout design:

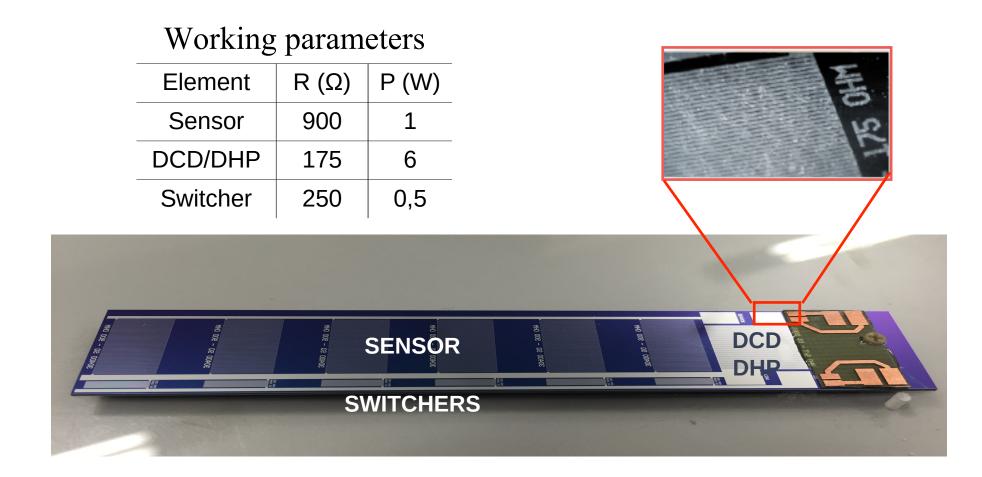


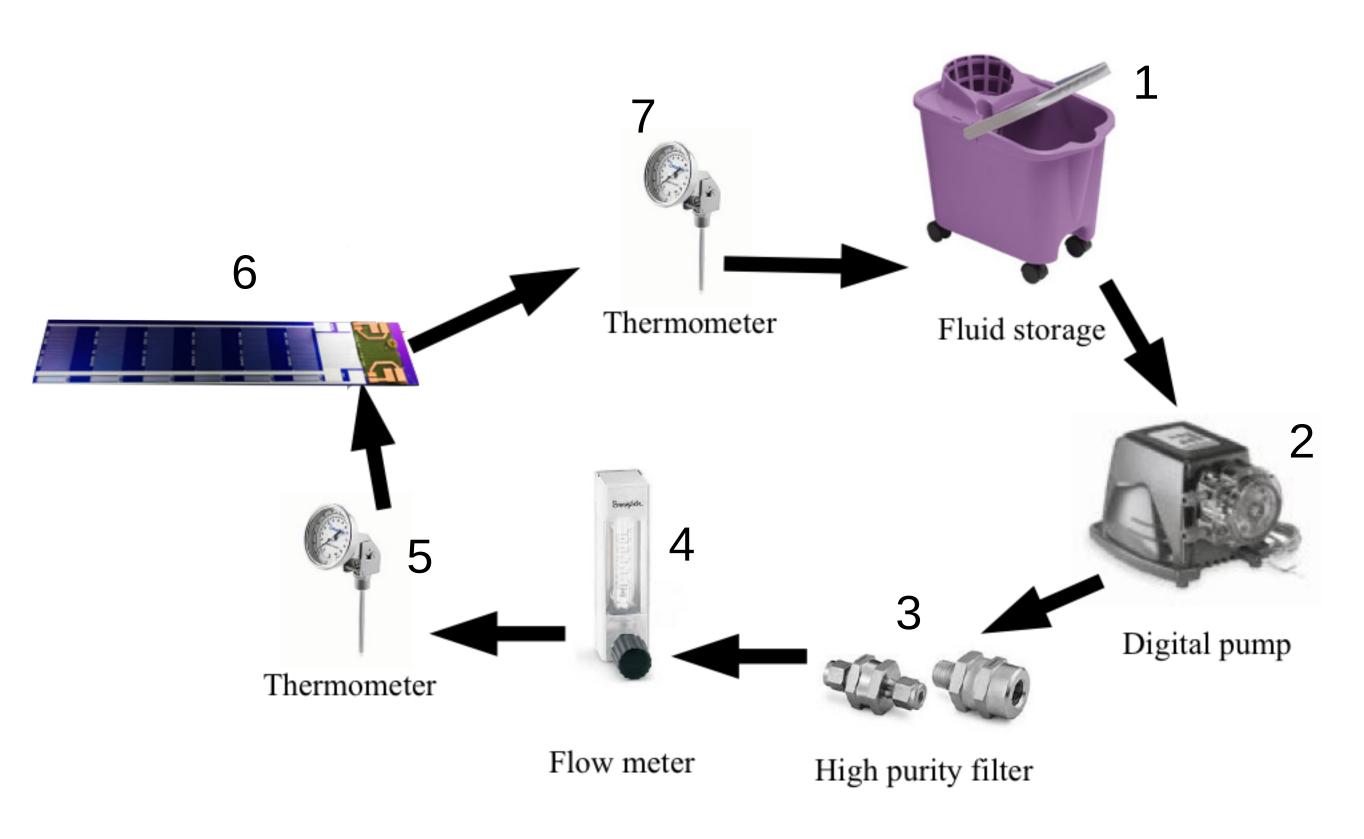


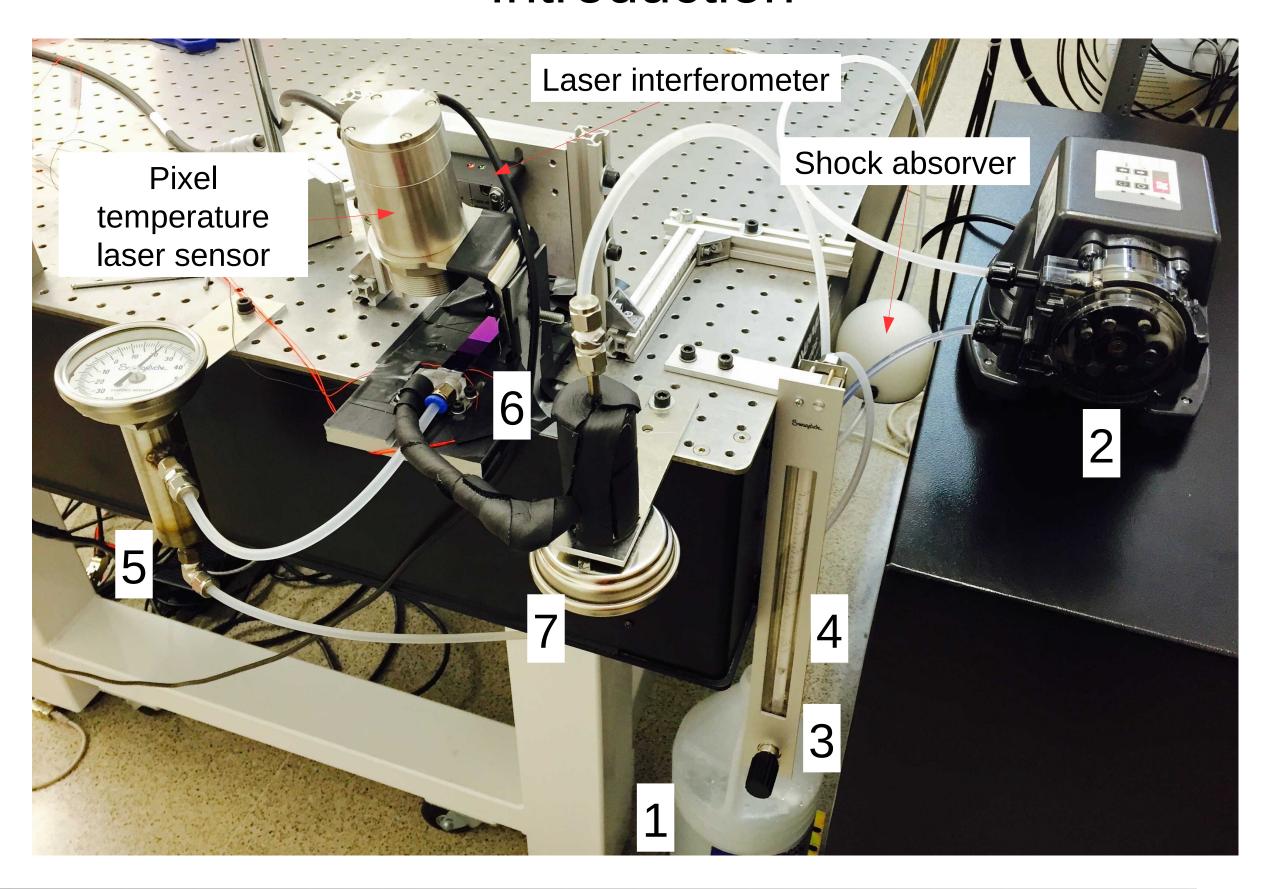
Inlet and outlet: \sim 380 x 340 μm

The resistive dummies with integrated micro-channels based in DEPFET layout design:

- Si modules with the designed dimensions of the DEPFET detectors
- Homogeneous thickness (thinned sensor area not needed)
- Modules do not include the real electronics
- Aluminum layer with resistor meanders on thin top wafer -> simulate the power distribution

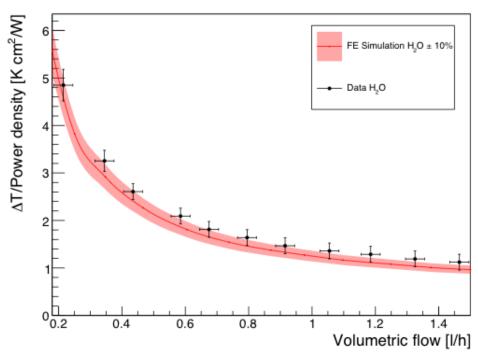




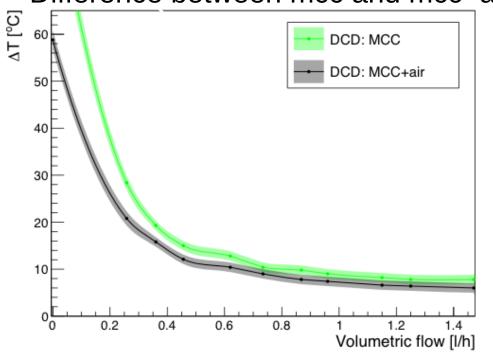


Past results

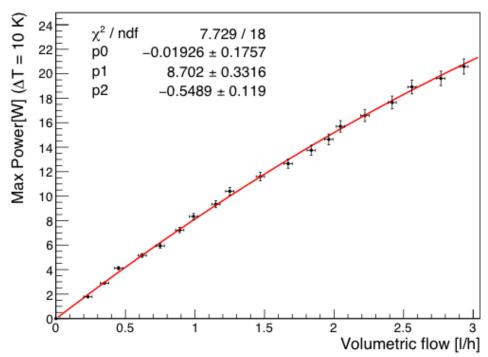
TFM: lab vs sim results



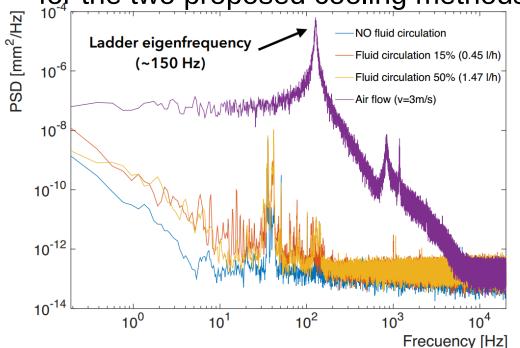
Difference between mcc and mcc+air



Max. power for $\Delta T=10K$



First frequency mode and deformation influence for the two proposed cooling methods



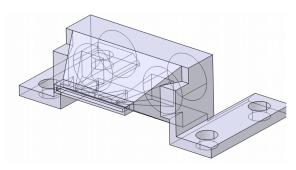
More information available in JINST, Volume 11, June 2016

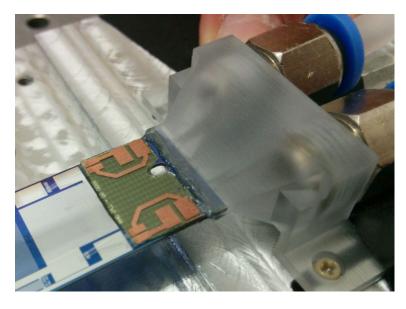
Problems	Solution
High amount of material for connexion between tubes and silicon microchannel ladder	

Problems	Solution
High amount of material for connexion between tubes and silicon microchannel ladder	Connector optimization

MCC optimization: material budget

Past (A long time ago,...)
(0.81% X/X₀)

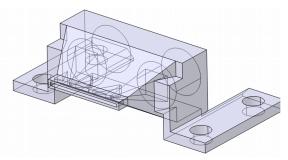


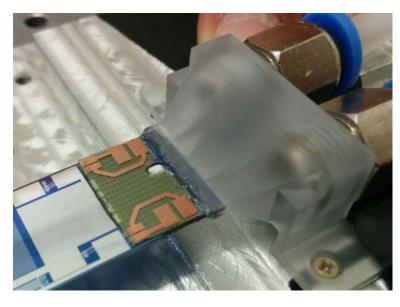


- First successful attempt
- Huge amount of material used: connector and metal fittings
- Mechanical fitting
- Non high performance glue

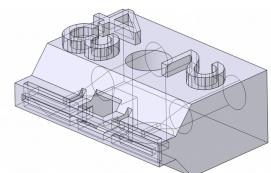
MCC optimization: material budget

Past (A long time ago,...)
(0.81% X/X₀)





Past (A not so long time ago)
(0.2% X/X₀)

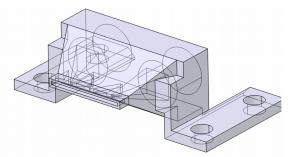


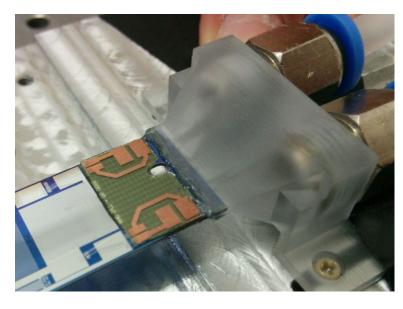


- First successful attempt
- Huge amount of material used: connector and metal fittings
- Mechanical fitting
- Non high performance glue
- Low amount of material used: connector and peek fittings
- Mechanical fitting
- High performance glue Araldite
- $2020 \rightarrow low \ viscosity \rightarrow clogging$

MCC optimization: material budget

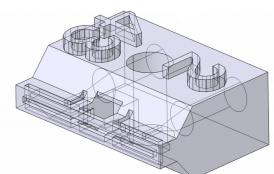
Past (A long time ago,...)
(0.81% X/X₀)





- First successful attempt
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- Non high performance glue

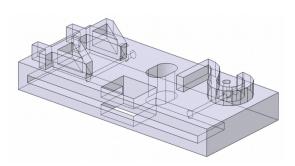
Past (A not so long time ago) $(0.2\% X/X_0)$

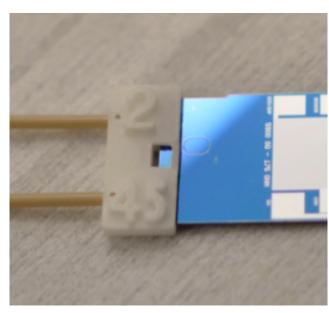




- Low amount of material used: connector and peek fittings
- Mechanical fitting
- High performance glue Araldite 2020 → low viscosity → clogging

Present (0.05% X/X₀)





- Low amount of material used: connector and peek fittings
- Chemical fitting
- High performance glue
 Araldite 2011 → high viscosity
 → no clogging

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3D printed materials radiation resistance is unknown	

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MCC optimization: connectors material



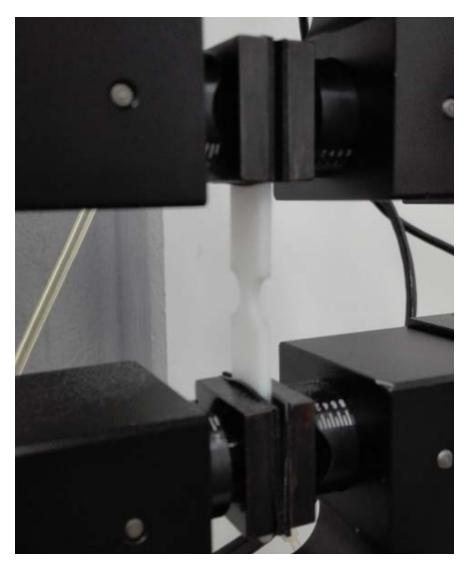
Different radiations levels

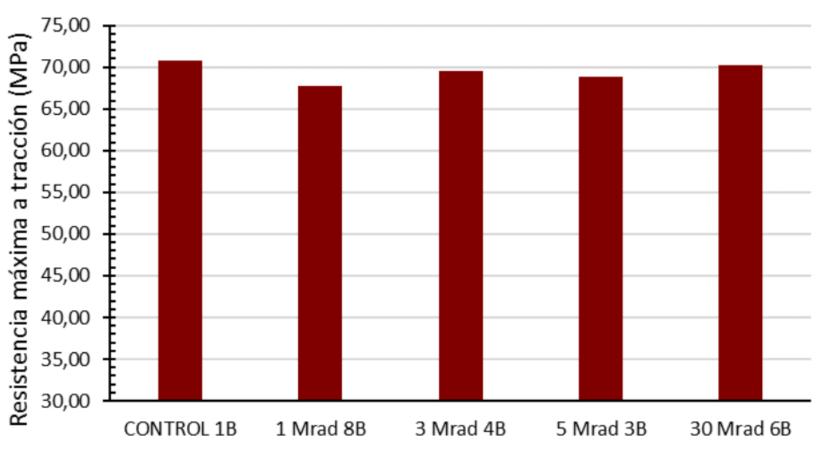
Two type of radiation:

- Neutrons
- X-Rays

MCC optimization: connectors material



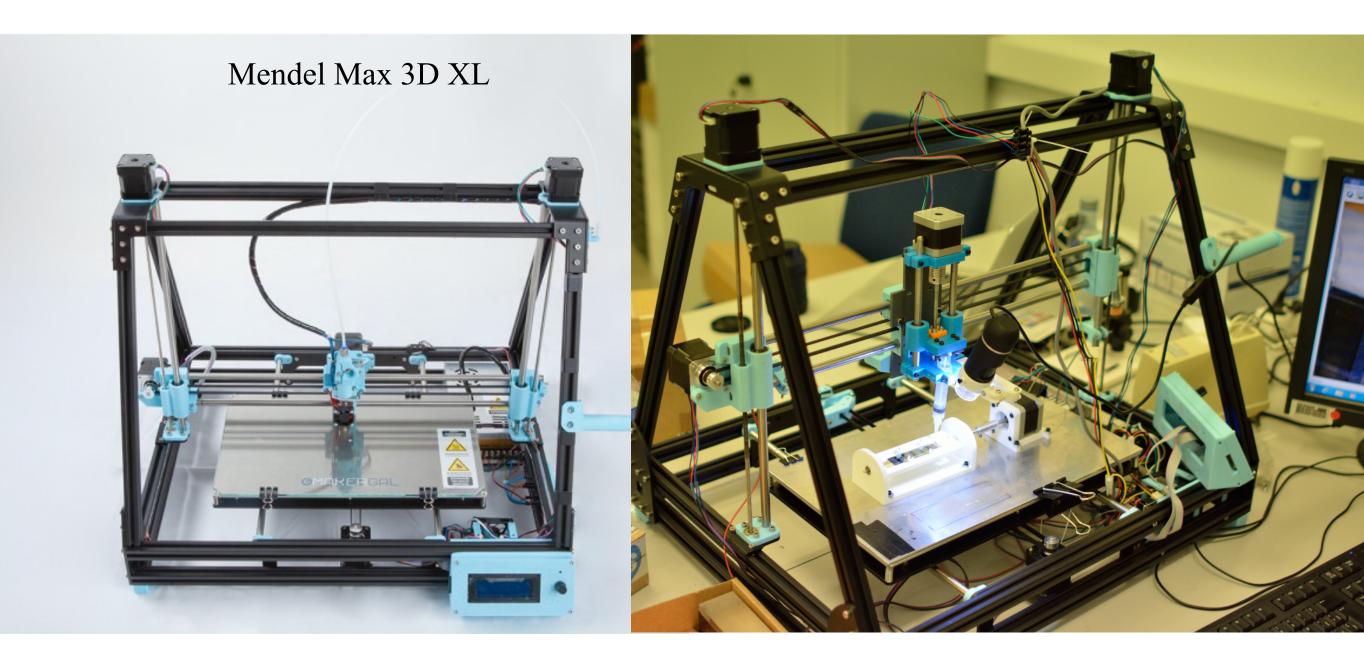




Problems	Solution
High amount of material for connexion between tubes and silicon microchannel ladder	Connector optimization
3D printed materials radiation resistance is unknown	Ultimate tensile strength test needed for different irradiated samples
Manual gluing process which brings to a dependency of random factors: subtle manipulation, luck,	

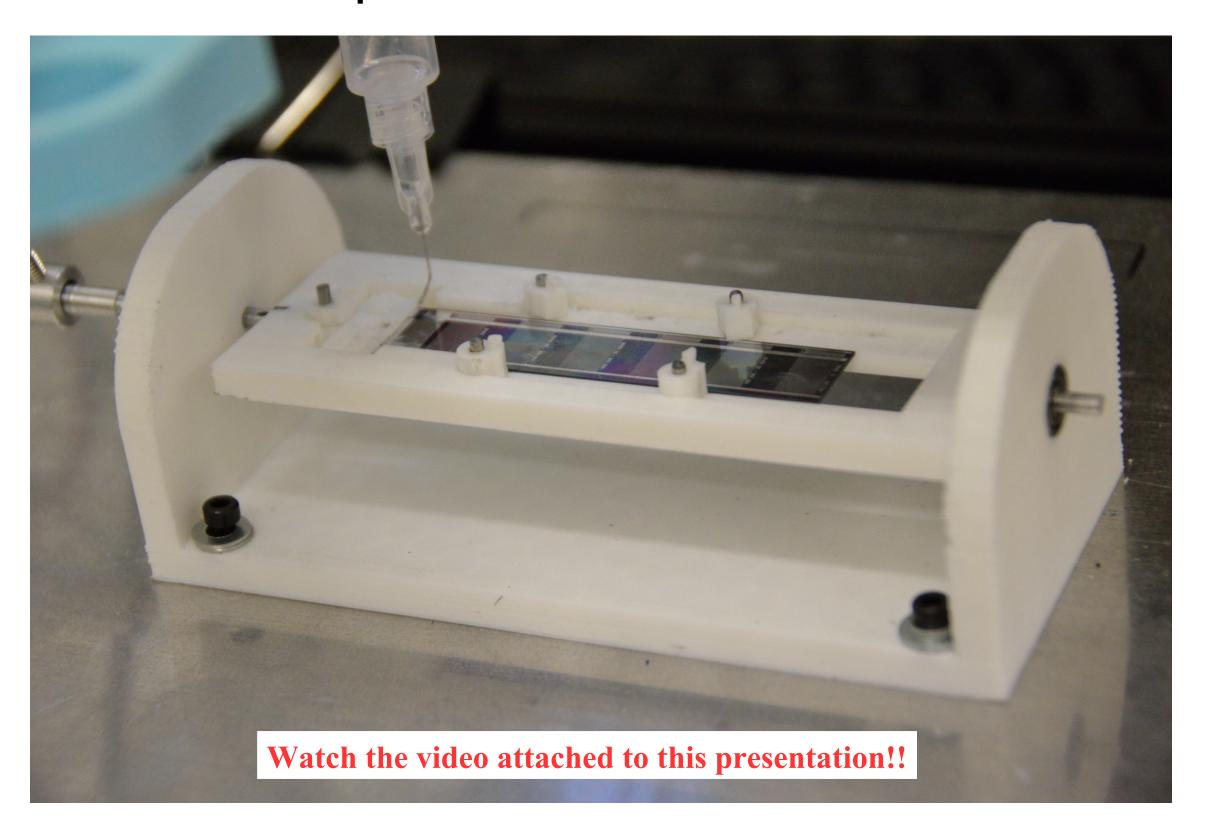
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MCC optimization: automatization



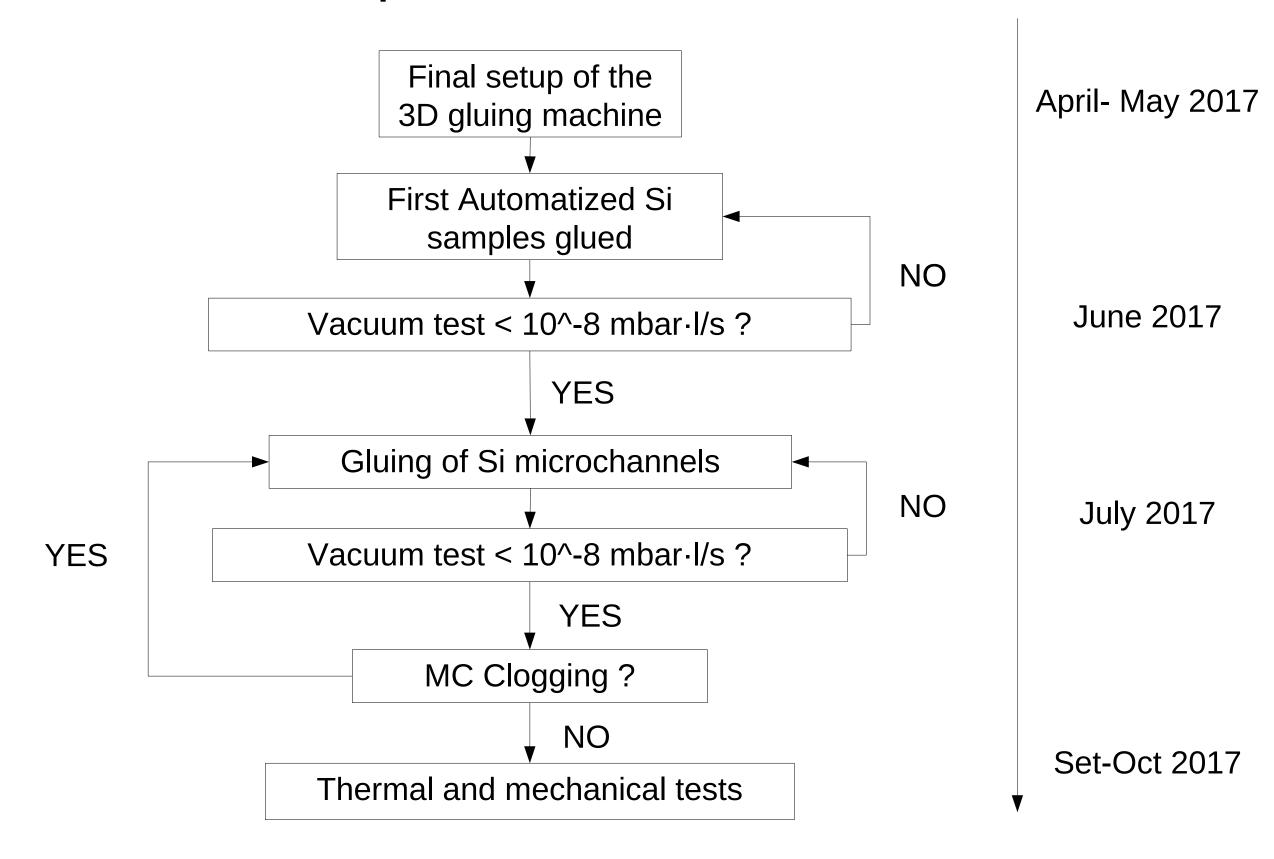
- Low cost machine
- Open hardware and software
- Needing to adapt tooling for needle and glue syringe

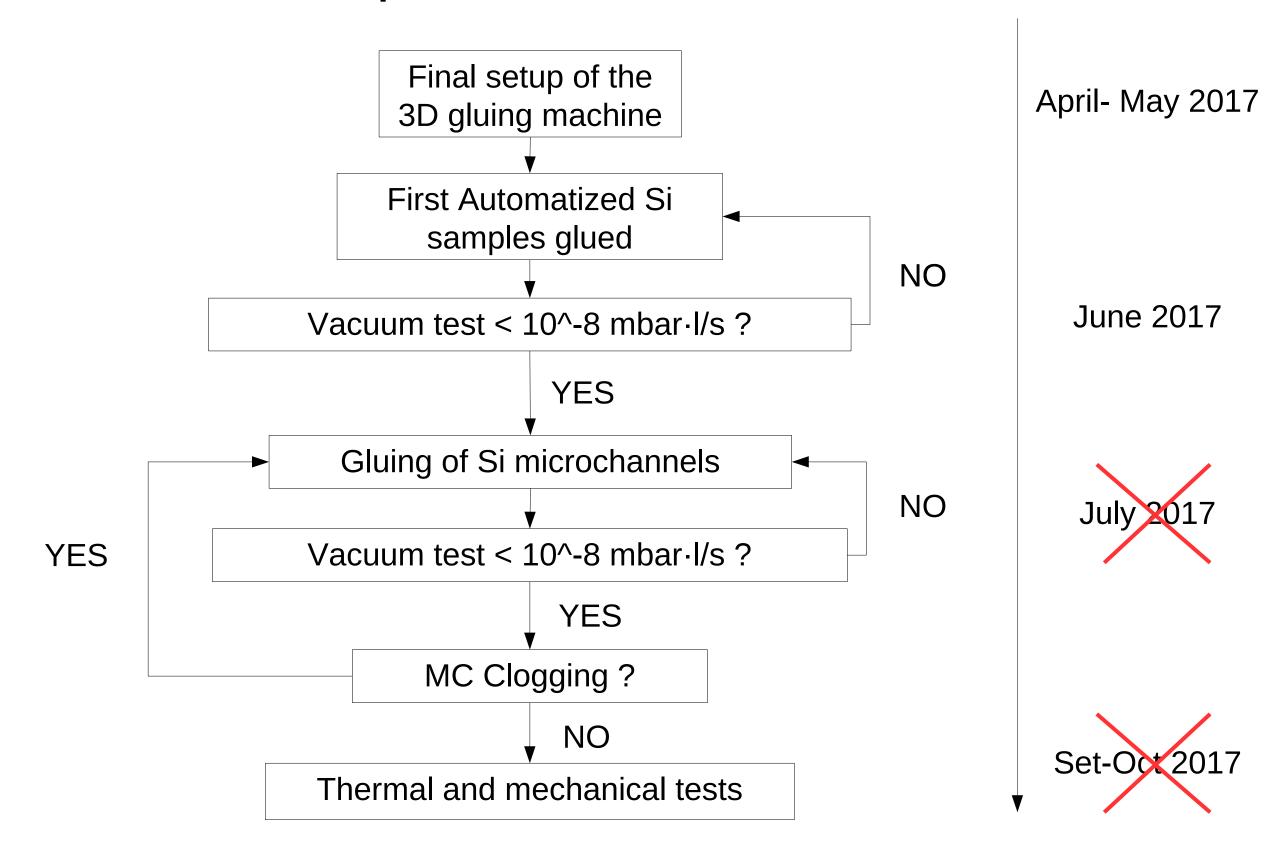
MCC optimization: automatization

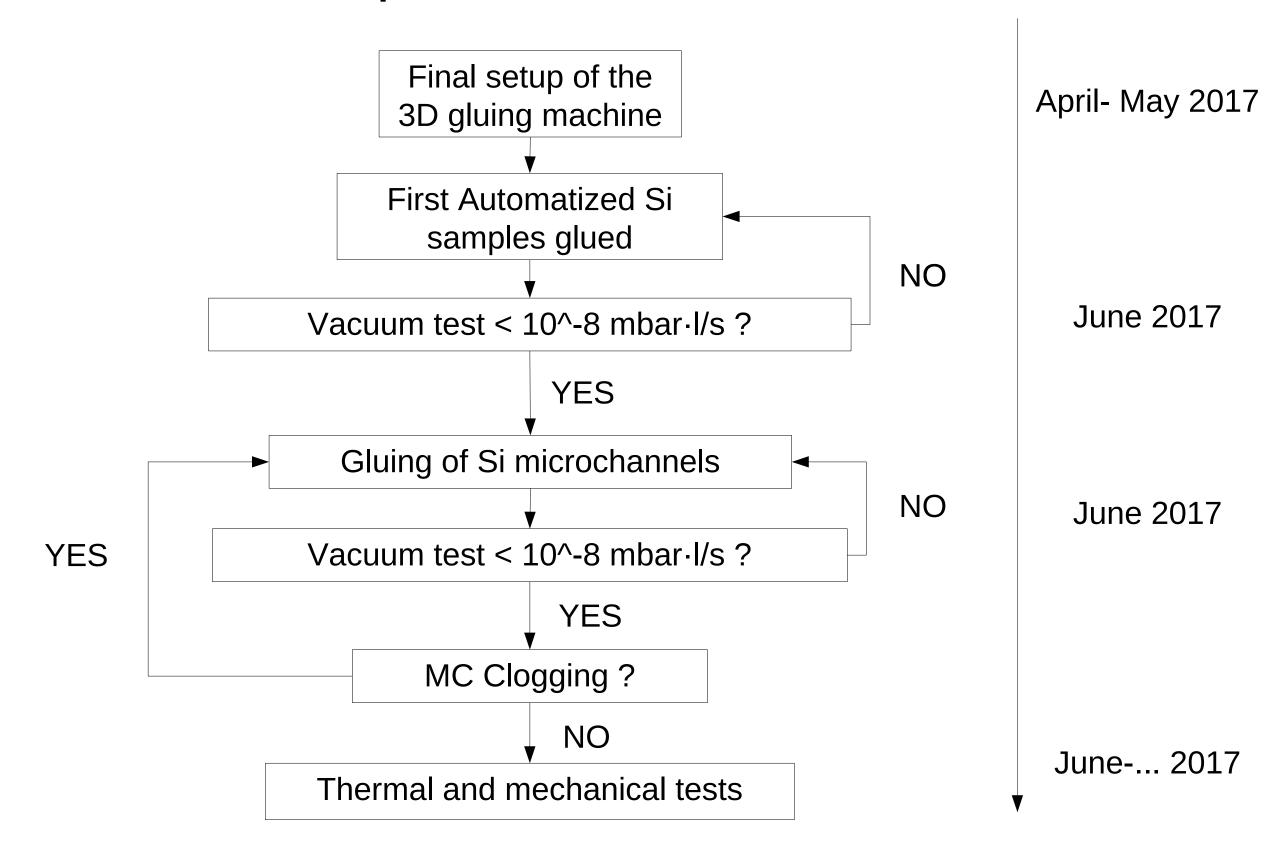


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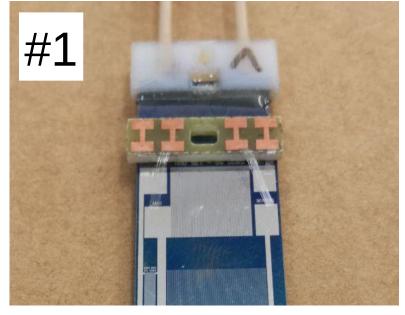




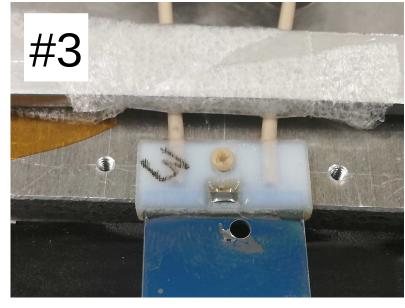




Sample number	#1	#2	#3	#4
Vacuum test [mbar l/h]	5,5e^-9	9,0e^-9	8,6e^-9	6,1e^-9





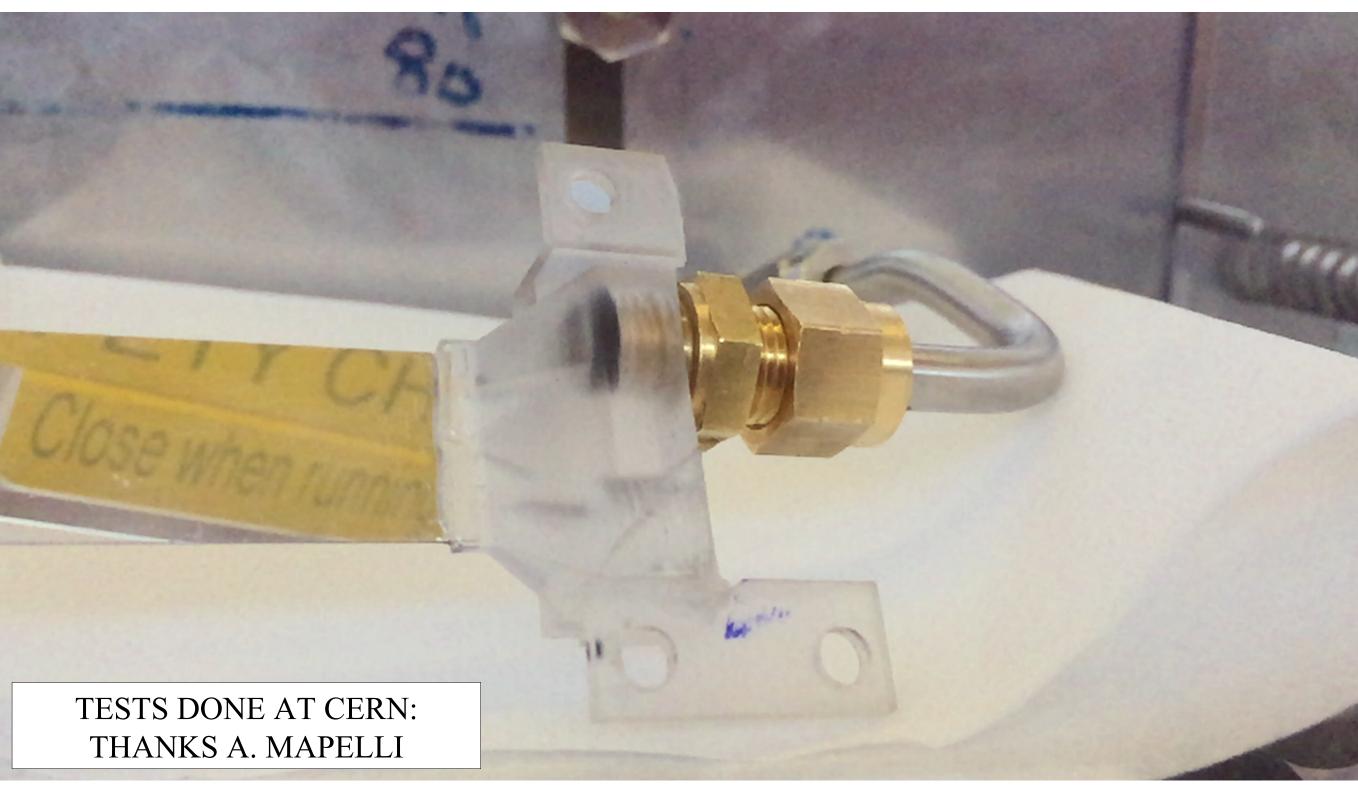




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Unknown pressure resistance of 3D printed material and silicon microchannels	

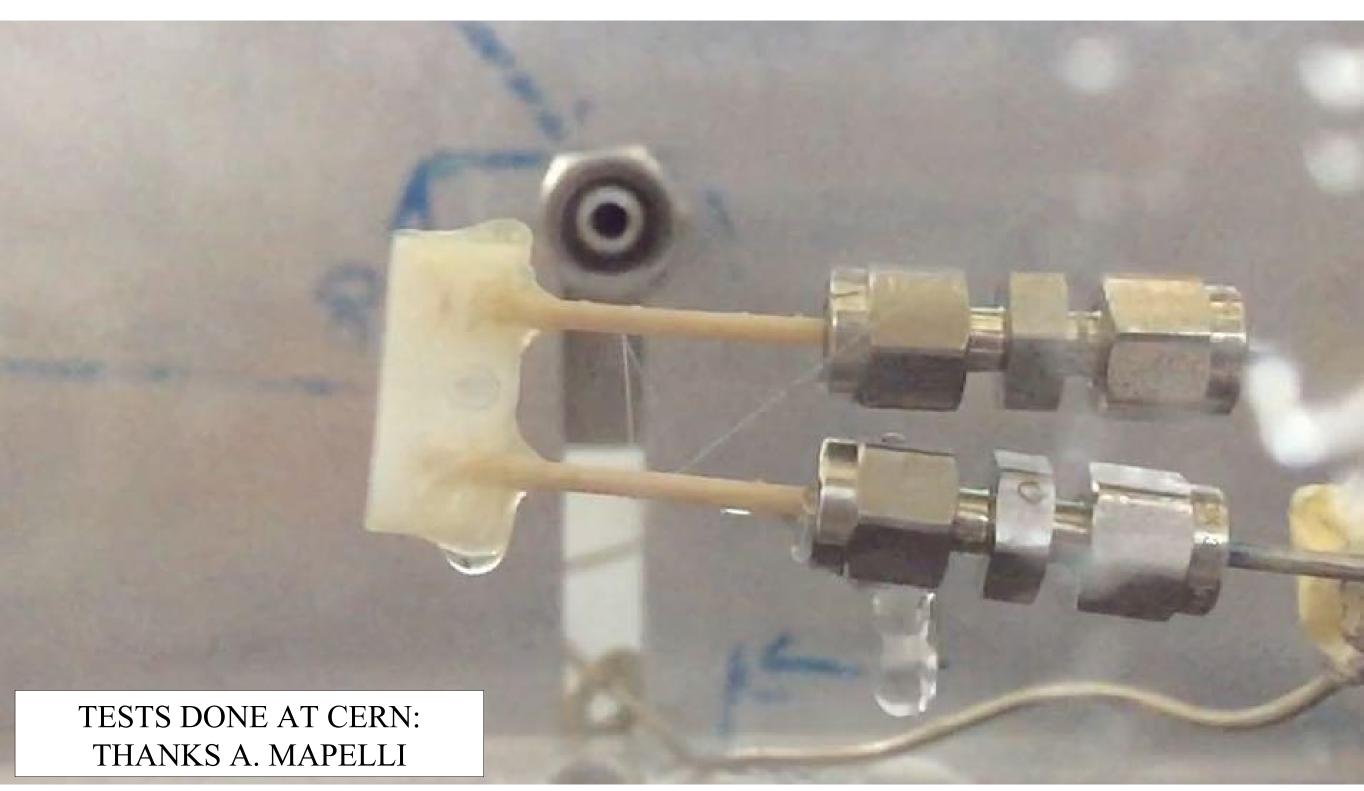
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MCC optimization: pressure test



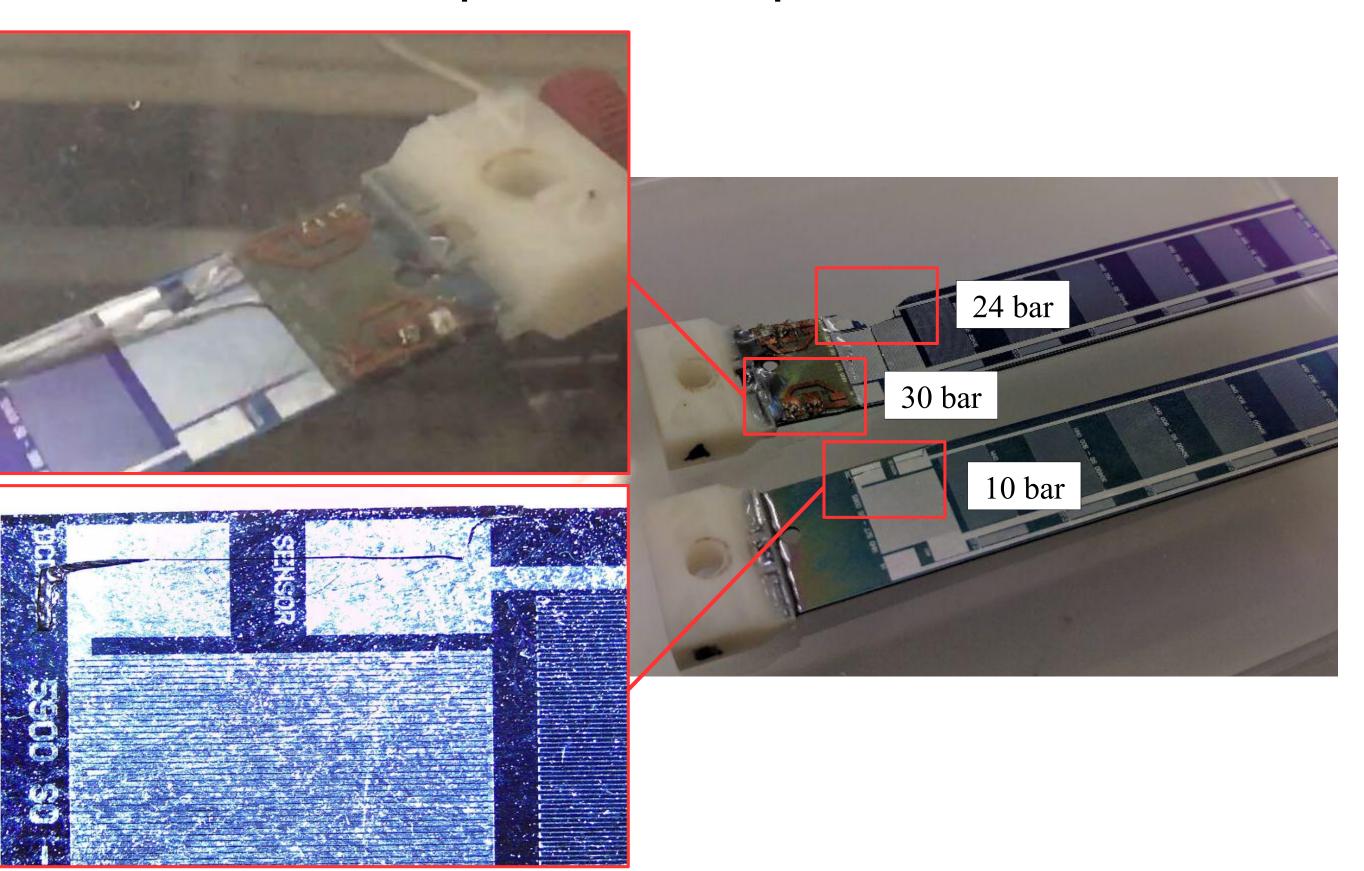
180 bar achieved

MCC optimization: pressure test



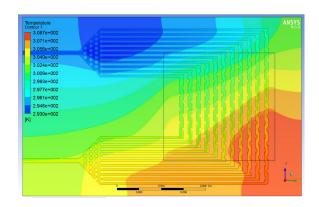
50 bar achieved

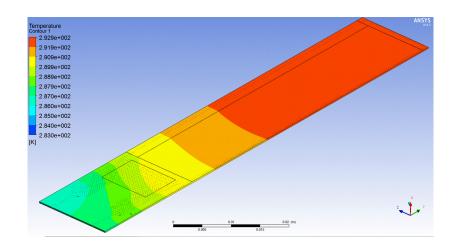
MCC optimization: pressure test

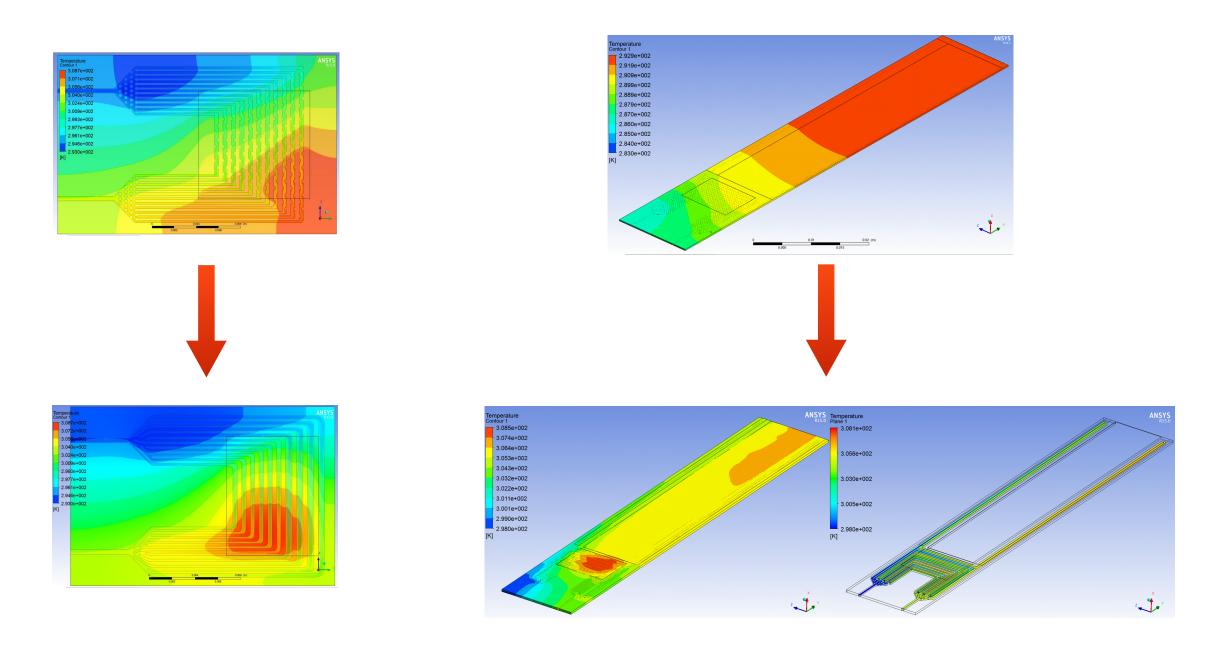


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Thermal gradient in sensor area and no cooling in switchers and sensor region	

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Thermal gradient in sensor area and no cooling in switchers and sensor region	Microchannel new layout

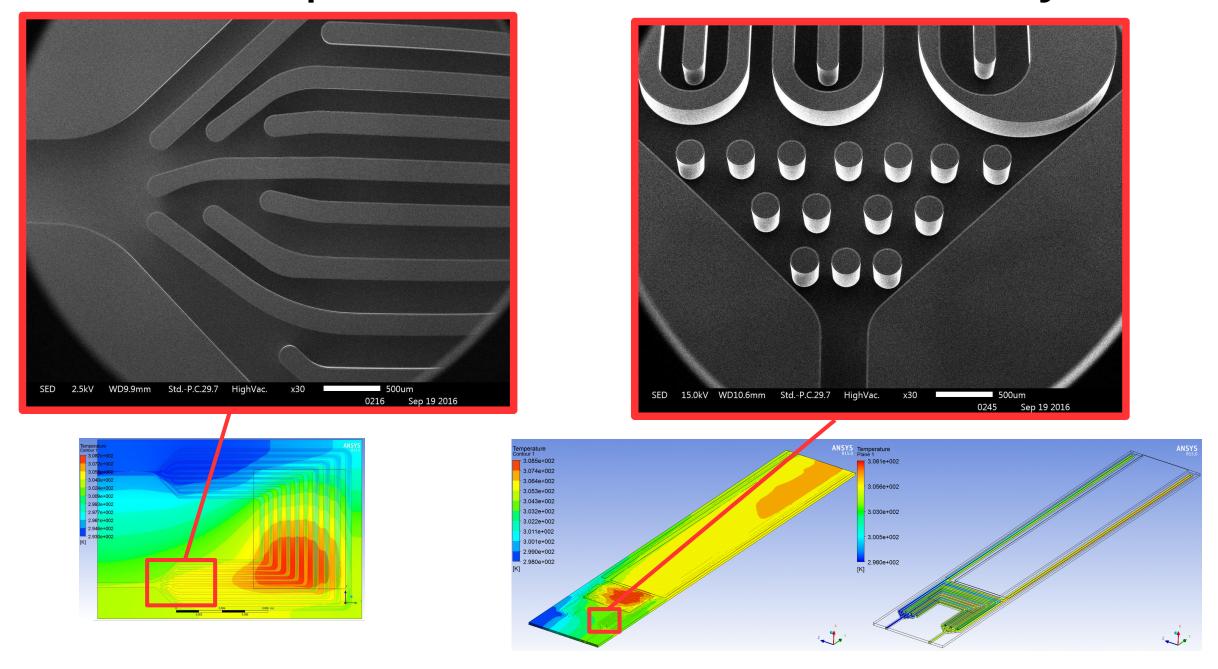






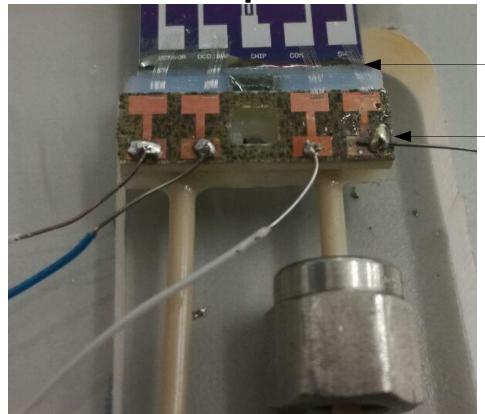
New mcc layout have been manufactured:

- Optimized layout for mcc: simulations predict better performance
- Mcc along all the heat sources



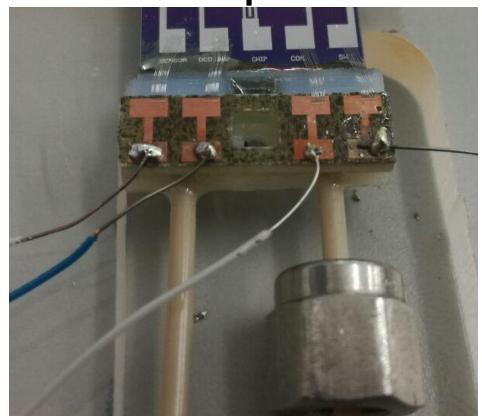
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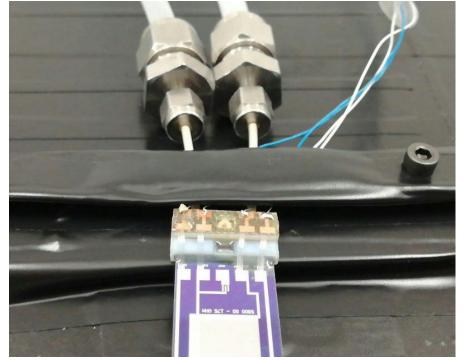


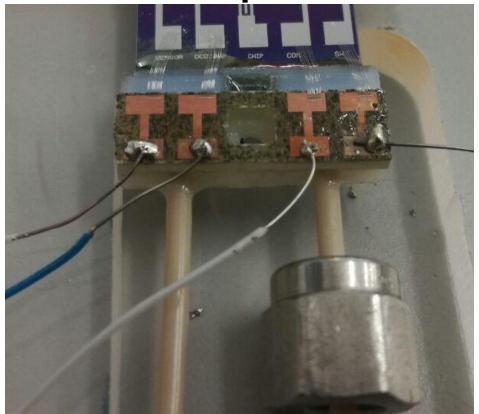
Wirebonding

Cable welding

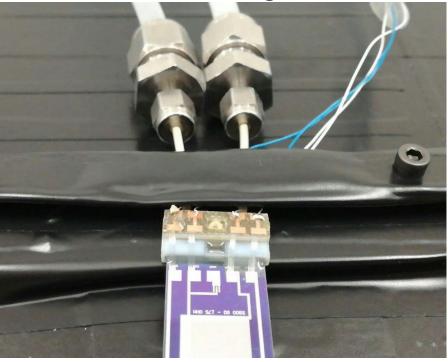


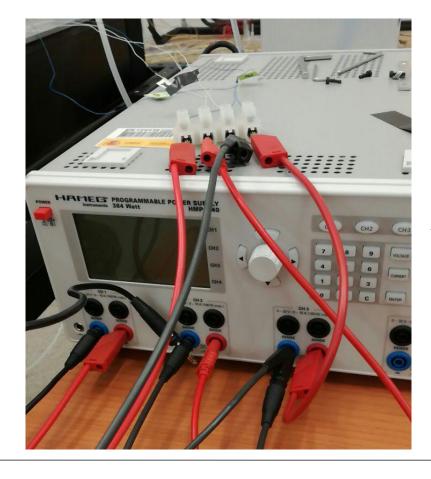
Tubes fittings



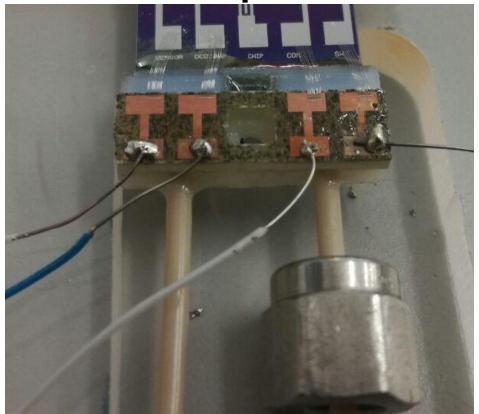


Tubes fittings

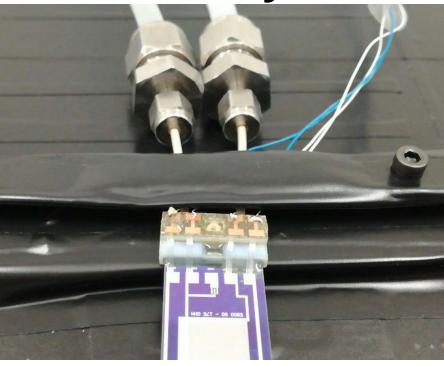


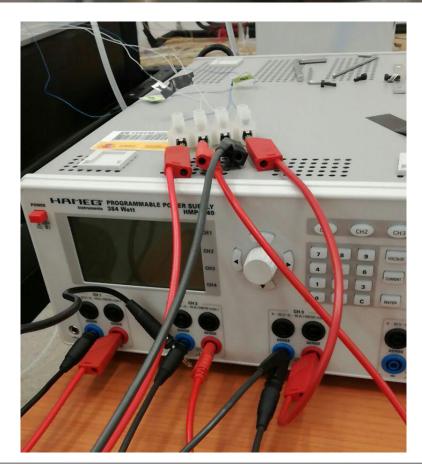


Power Connexion



Tubes fittings



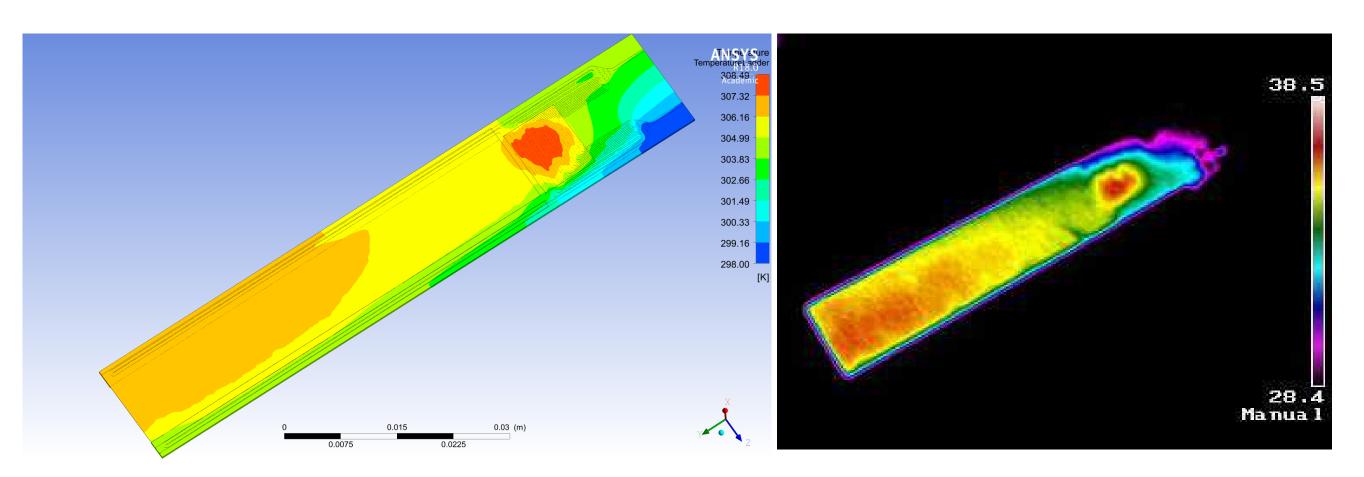


Power Connexion

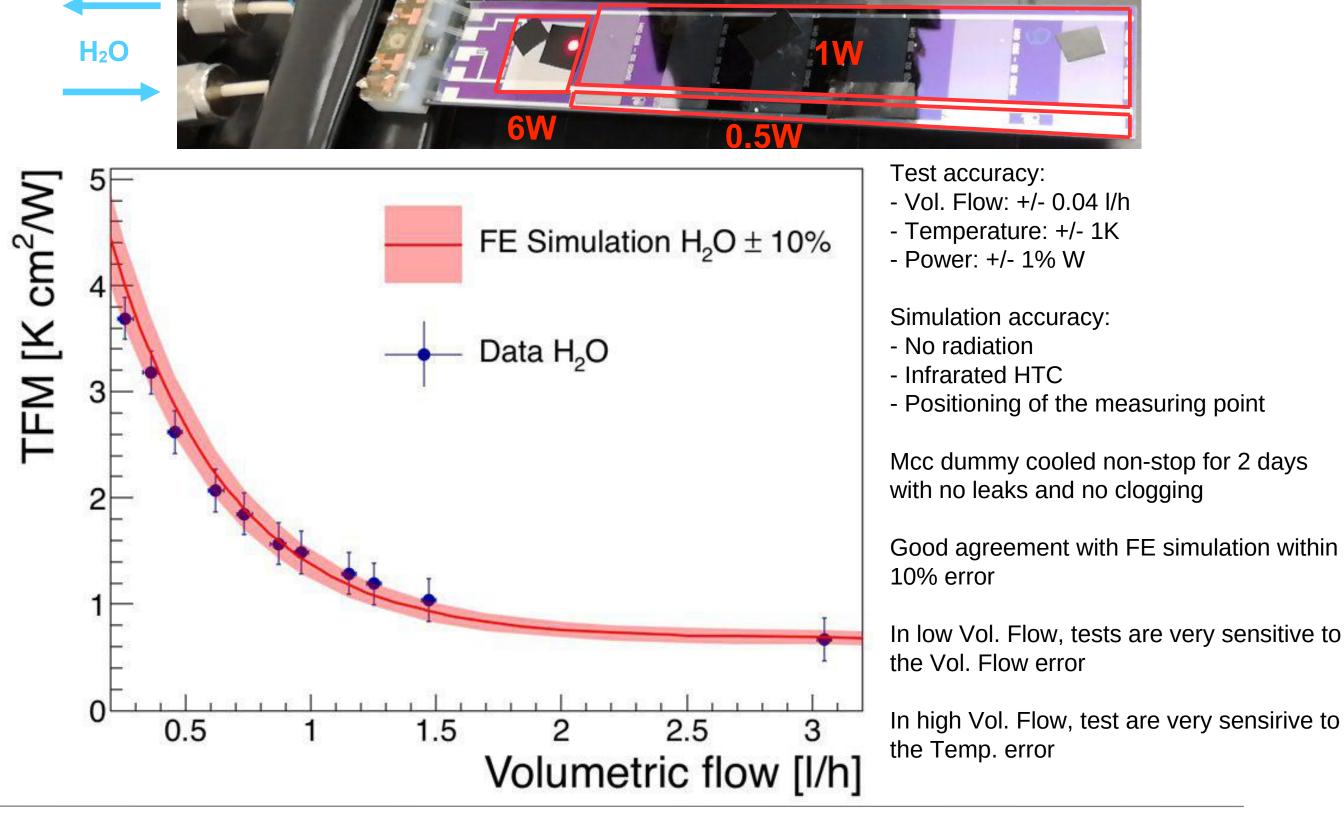








- Inlet in the simulation is the outlet in the test
- Thermal camera inside black box
- Simulation $\Delta T=10,5K$ and test $\Delta T=10,1K$



(still) Future work

- More accurate measurements (those are very preliminary)
- Other fluids
- Test bumpboundigs chips
- Test active sensors
- Flex cable for powering
- Optimize amount of glue
- Are irradiated material results acceptable??

Summary

- Microchannels new layout designed, manufactured and working as expected
- Gluing repeatability obtained by hacking a 3D printer machine
- Optimization (material budget, integration) and validation (pressure, radiation hardness) of the 3D printed connector done
- In plane mcc connexion is possible maintaining low material budget
- 3D gluing machine vacuum tests under 10^-8 mbar l/s
- Pressure test done in 3D printed material for connector and microchannels